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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE
(Atty. Docket No. 100176)

First Inventor: Roland K. SEVILLA

Serial No.: 10/601,601

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Art Unit: 3723

Title: POLISHING PAD FOR
ELECTROCHEMICAL-MECHANICAL
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OFFICE ACTION RESPONSE

In response to the Office Action of November 9, 2005, please enter the following remarks into the record for this application.

Remarks/Arguments begin on page 2 of this paper.

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